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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re the Application of:

MIZUHARA et al.

Serial No.: 09/037,674

Filed: March 9, 1998

Atty. File No.: 2933SE-11-CIP-2

For: "SEMICONDUCTOR DEVICES
PASSIVATION FILM"Assistant Commissioner for Patents
Washington, D.C. 20231

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SUPPLEMENTAL INFORMATION
DISCLOSURE STATEMENT

CERTIFICATE OF MAILING	
I HEREBY CERTIFY THAT THIS CORRESPONDENCE IS BEING DEPOSITED WITH THE UNITED STATES POSTAL SERVICE AS FIRST CLASS MAIL IN AN ENVELOPE ADDRESSED TO COMMISSIONER OF PATENTS AND TRADEMARKS, WASHINGTON, DC 20231 ON JUNE 25, 1999	
BY:	SHERIDAN ROSS P.C. <i>Genda Carpenter</i>

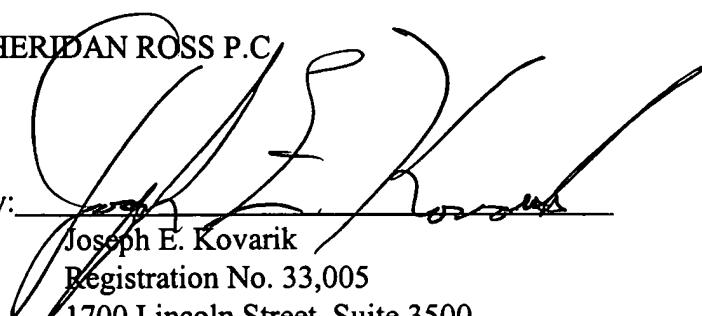
Dear Sir:

Pursuant to Applicants' duty of disclosure under 37 CFR § 1.56 and 37 CFR §§ 1.97-1.98, Applicants hereby submit the enclosed PTO Form 1449. The documents identified herein were of record in U.S. Patent Application Serial No. 08/766,931, and since the above-identified patent application is a continuation thereof, copies of the identified documents are not being submitted under 37 CFR § 1.98(d). Applicants do not admit that any of such documents, alone or in any combination, is considered to be material to patentability as defined in 37 CFR § 1.56(b). Moreover, the inclusion of these documents is not to be construed as an admission by Applicants that each such document is prior art as to the above-identified patent application.

Respectfully submitted,

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